LEAD FRAME

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Abstract

inner lead part 2b and the different material can be formed of a lead 2 is made rough by lapping, press or the like, and the adhesion of the inner lead part is made good. Or a partial plated layer 6 is provided CONSTITUTION:For an outer lead part 2a, a material having a smooth surface roughness is used. Thus adhesion is made low and the burr of a molding resin is hard to attach. Therefore the deburring becomes easy. The surface roughness of the material of only the part of an inner lead part 2b the inner lead part 2b. The wire bonding between a semiconductor element 8 and the lead 2 is made easy. Or a plated layer 7 is attached only to the of a molding resin, by differentiating the surface roughnesses and the surface materials of an outer lead part and an inner lead part. PURPOSE:To improve moisture resistance with respect to a semiconductor element, which is enclosed in a package, and to facilitate the deburnng

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